

Drawing Number Series List

100	2 GeV
800	2 GeV
900	2 GeV
1200	2 GeV
1300	C-Bug
1400	Cosmic Ray
1500	Chem Room
1500-100 thru 1900	
2000	2 GeV
2100	2 GeV
2200-2400	
2500	2 GeV
2600-2900	
3000	10 GeV (Mech)
3100	10 GeV (Mech)
3200	10 GeV (Mech)
3300	10 GeV (Mech)
3400	Panels & Miscellaneous Electrical
3500	RF (Elect)
3600	Multiplex (MPX)(Elect)
3700	Power (Elect)(General)
3750	Magnet Excitation (Elect)
3800	Linac & Injection System
3850	Detection (Beam Monitor etc.)(Elect)
3900	Experimental (Beam Use)(Elect)
3950	Digital Voltmeter (DVM)(Elect)
4000	Control
4100	Control
4200	Control
4300	Control
4400	Control
4500	Control
4600	Control
4700	Control
4800	Control
4900	Control
5000	Balloon Experiment (K. Greisen)
5025	Experimental Imagineering
5050	High Energy 50 x 50 (General)
5051	Electronics Shop (J. Barley)
5052-5054	
5055	SRF Systems
5056-5058	

5059	Cryogenics
5060-5900	
5299	Meyer Tool Mfg SRF Cryostat
6000	Mu Pairs
6001	Pair Spectrometer
6002	KO Production
6003	Wide Angle Bremsstrahlung (WAB)
6004	Backward Production (BP)
6005	Omega (OM)
6006	Clasp
6007	Tag Photons (TAG)
6008	ETA Production (ETA)
6009	Electron Scattering (ES)
6010	Backward Rho Meson (SCEW)
6011	Compton Scattering
6012	External Beam (Exit)
6013	Deep Inelastic Muon Scattering (MUSE)
6014	Cornell Precision Spectrometer
6015	Large Aperture Magnet Experiment (LAME)
6016	DECO
6017	TUMM (SG)
6018	Fermilab
6019	CHESS
6019-200	CHESS G-Line
6019-300	
6019-400	CHESS E-Line
6020-6039	
6040	CESR General & Building Plans
6041	Magnets & Magnet Supports (CESR)
6042	Magnet Power Supplies (CESR)
6043	Linac (CESR)
6044	Ext. Inj. & Beam Transport Equipment (CESR)
6045	RF Systems (CESR)
6046	Vacuum System (CESR)
6047	Computer Interface & Timing Elect (CESR)
6048	Beam Monitor & Beam Control
6049	New Electron Snout 1990 (CESR)
6050	CESR Magnetic Detector (CLEO 1)
6051	CESR High Intensity Linac Injector (CHILI)
6052-000	Drift Chamber (CLEO 2)
6052-100	Shower Counter Barrel (CLEO 2)
6052-200	Shower Counter Pole Tip (CLEO 2)
6052-300	Magnet Yoke (CLEO 2)
6052-400	Time Of Flight (TOF)(CLEO 2)
6052-500	Coil Cryogenics (CLEO 2)

6052-600	Electronics (CLEO 2)
6052-700	Miscellaneous (CLEO 2)
6052-800	Vertex Detector (CLEO 2)
6052-900	
6053	Ultra High Vacuum Furnace
6054	CESR+
6055-000	B Factory Proposal
6055-100	CLEO Phase 2.5 - Electronics
6055-200	CLEO Phase 2.5 - Silicon Detector
6055-300	CLEO Phase 2.5 - Particle Identification
6055-400	CLEO Phase 2.5 - Trigger
6055-500	CLEO Phase 2.5 - Data Acquisition
6055-600	CLEO Phase 2.5 - Magnet Yoke
6055-700	CLEO Phase 2.5 - Cryogenics
6056-000	CESR Phase 2 - Interaction Region Equipment
6056-100	CESR Phase 2 - Magnets
6056-200	CESR Phase 2 - Electrical
6056-300	CESR Phase 2 - Vacuum
6056-400 thru 900	
6057-000 thru -049	CLEO Phase 3 - Drift Chamber (DR3)
6057-050 thru -099	CLEO Phase 3 - Inner Drift Chamber (LOEN)
6057-100	CLEO Phase 3 - Electronics
6057-200	CLEO Phase 3 - Silicon Detector
6057-300	CLEO Phase 3 - Particle Identification (RICH)
6057-400	CLEO Phase 3 - Trigger
6057-500	CLEO Phase 3 - Data Acquisition
6057-600	CLEO Phase 3 - Magnet Yoke
6057-700	CLEO Phase 3 - Infrastructure
6057-800	CLEO Phase 3 - General
6057-900	CLEO Phase 3 - Calorimeter
6058-000	CESR Phase 3 - Interaction Region
6058-100	CESR Phase 3 - Interaction Region
6058-200	CESR Phase 3 - Electronics
6058-300 thru 900	
6059-000	CESR Phase 4
6059-100	CESR Phase 4 - R&D
6059-200 thru 500	
6059-600	CESR Phase 4 - Magnets
6059-700	CESR Phase 4 - Magnets (Reserved)
6059-800	CESR Phase 4 - Magnets (Reserved)
6059-900	CESR Phase 4 - Transfer Lines
6060-000	CESR Phase 2/3 Hybrid (IR Only)
6060-100 thru 900	

6099	Standard Survey Fixtures (S. Chapman)
6070	Charm Factory (CLOEN)
6070-200	CESR-C Wiggler Electronics
6075	Superconducting Interaction Region (SCIR)
6080	Linear Collider R&D
6100 thru 6600	
6700	Computer
6800	
6900	
7000	General Experiment

7100 7110	ERL
7100-000	General dwgs (site, building, utilities, HVAC, infrastructure...)
7101-000	Electron Source (including laser & optical beam dist, Gun HVPS etc)
7102-000	Injector Cryomodule
7103-000	Main Linac Cryomodule
7104-000	RF Systems (including RF Power dist, buncher activity etc)
7105-000	Cryogenic Systems (refrig, cryogen dist, cryo instrumentation)
7106-000	Vacuum Systems (including cryomodule insulating vacuum, roughing stations, beam dump)
7107-000	Magnets (including magnet power supplies??)
7108-000	Beam Diagnostic Systems
7109-000	Controls (RF controls etc)

7200 thru 7900

8000	10 GeV (Mech)
8100	10 GeV (Mech)
8200 thru 8900	

9000	Linac & Injection System
9100	
9200	Cryogenic RF (CRF)
9300 thru 9999	